



IFW 2871

PATENT APPLICATION

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Mutsumi KIMURA et al.

Group Art Unit: 2871

Application No.: 09/077,029

Examiner: A. SCHECHTER

Filed: May 18, 1998

Docket No.: JAO 40499

For: MATRIX TYPE DISPLAY DEVICE AND MANUFACTURING METHOD THEREOF

AMENDMENT IN RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Prior to substantive examination, please amend the above-identified application as follows:

Amendments to the Claims as reflected in the listing of claims;

Remarks.